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प्रश्नपुस्तिका क्रमांक
Question Booklet No.

O.M.R. Serial No.

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प्रश्नपुस्तिका सीरीज
Question Booklet Series

C

**M.Sc (Electronics) Third Semester,
Examination, February/March-2022
ELC-302(N)
IC Technology and VLSI Design**

Time : 1:30 Hours

Maximum Marks-100

जब तक कहा न जाय, इस प्रश्नपुस्तिका को न खोलें

- निर्देश : —
1. परीक्षार्थी अपने अनुक्रमांक, विषय एवं प्रश्नपुस्तिका की सीरीज का विवरण यथास्थान सही- सही भरें, अन्यथा मूल्यांकन में किसी भी प्रकार की विसंगति की दशा में उसकी जिम्मेदारी स्वयं परीक्षार्थी की होगी।
 2. इस प्रश्नपुस्तिका में 100 प्रश्न हैं, जिनमें से केवल 75 प्रश्नों के उत्तर परीक्षार्थियों द्वारा दिये जाने हैं। प्रत्येक प्रश्न के चार वैकल्पिक उत्तर प्रश्न के नीचे दिये गये हैं। इन चारों में से केवल एक ही उत्तर सही है। जिस उत्तर को आप सही या सबसे उचित समझते हैं, अपने उत्तर पत्रक (O.M.R. ANSWER SHEET) में उसके अक्षर वाले वृत्त को काले या नीले बाल प्वाइंट पेन से पूरा भर दें। यदि किसी परीक्षार्थी द्वारा निर्धारित प्रश्नों से अधिक प्रश्नों के उत्तर दिये जाते हैं तो उसके द्वारा हल किये गये प्रथमतः यथा निर्दिष्ट प्रश्नोत्तरों का ही मूल्यांकन किया जायेगा।
 3. प्रत्येक प्रश्न के अंक समान हैं। आप के जितने उत्तर सही होंगे, उन्हीं के अनुसार अंक प्रदान किये जायेंगे।
 4. सभी उत्तर केवल ओ०एम०आर० उत्तर पत्रक (O.M.R. ANSWER SHEET) पर ही दिये जाने हैं। उत्तर पत्रक में निर्धारित स्थान के अलावा अन्यत्र कहीं पर दिया गया उत्तर मान्य नहीं होगा।
 5. ओ०एम०आर० उत्तर पत्रक (O.M.R. ANSWER SHEET) पर कुछ भी लिखने से पूर्व उसमें दिये गये सभी अनुदेशों को सावधानीपूर्वक पढ़ लिया जाय।
 6. परीक्षा समाप्ति के उपरान्त परीक्षार्थी कक्ष निरीक्षक को अपनी प्रश्नपुस्तिका बुकलेट एवं ओ०एम०आर० शीट पृथक-पृथक उपलब्ध कराने के बाद ही परीक्षा कक्ष से प्रस्थान करें।
 7. निगेटिव मार्किंग नहीं है।
- महत्वपूर्ण : — प्रश्नपुस्तिका खोलने पर प्रथमतः जाँच कर देख लें कि प्रश्नपुस्तिका के सभी पृष्ठ भलीभाँति छपे हुए हैं। यदि प्रश्नपुस्तिका में कोई कमी हो, तो कक्ष निरीक्षक को दिखाकर उसी सीरीज की दूसरी प्रश्नपुस्तिका प्राप्त कर लें।

1. ASIC stands for _____.
 - (A) Application standard of integrated circuits
 - (B) Application-specific intercommunication circuit
 - (C) Application-specific integrated circuit
 - (D) American standard integrated circuit
2. CMOS technology is used in developing which of the following?
 - (A) Microprocessors
 - (B) Microcontrollers
 - (C) Digital logic circuits
 - (D) All of the mentioned
3. In NMOS device, gate material could be _____.
 - (A) Silicon
 - (B) Boron
 - (C) Polysilicon
 - (D) Phosphorus
4. In CMOS NAND gate, PMOS is connected in:
 - (A) Series
 - (B) Parallel
 - (C) Random
 - (D) None
5. Bipolar transistors are _____ than field effect transistor.
 - (A) Less sensitive and slower
 - (B) More sensitive and slower
 - (C) More sensitive and faster
 - (D) Less sensitive and faster

6. A sequential circuit contains combinational logic and storage elements in:
- (A) Output node
 - (B) Feedback path
 - (C) Input node
 - (D) Feed forward path
7. _____ layer should be over _____ layer used in stick diagram representation:
- (A) ntype, polysilicon
 - (B) polysilicon, ntype
 - (C) ptype, ntype
 - (D) ntype, ptype
8. Which occupies lesser area?
- (A) NMOS
 - (B) PMOS
 - (C) CMOS
 - (D) BiCMOS
9. Co-ordination number of a crystalline solid is:
- (A) Number of particles in the unit cell
 - (B) Number of nearest neighbours of a particle
 - (C) Number of octahedral voids in a unit cell
 - (D) Number of tetrahedral voids in a unit cell
10. Multipliers are built using:
- (A) Binary adders
 - (B) Binary subtractors
 - (C) Dividers
 - (D) Multiplexers

11. In BiCMOS inverter, the BJT used are _____.
(A) Only npn BJT
(B) Only Pnp BJT
(C) Both npn and pnp BJT
(D) Multi emitter npn BJT
12. Which of the following is a property of amorphous solids?
(A) Sharp melting point
(B) Isotropy
(C) Long range order
(D) Definite heat of Fusion
13. What is the advantage of using Czochralski & Bridgman method?
(A) Gives small crystals
(B) High tech apparatus
(C) Rapid growth rates
(D) Uses Plasma torch
14. Why MOSFET is preferred over BJT in IC components?
(A) It has low packing density
(B) It has medium packing density
(C) It has high packing density
(D) It has no packing density
15. The mobility is given by:
(A) $\mu = V_0/E_0$
(B) $\mu = V_0^2/E_0$
(C) $\mu = V_0/E_0^2$
(D) None of the above

16. MOSFET is used as _____.
(A) Current source
(B) Voltage source
(C) Buffer
(D) Divider
17. The saturation drain current I_{DS} is an FET equals:
(A) $I_{DSS} \left(1 - \frac{V_{GS}}{V_p}\right)^2$
(B) $I_{DSS} \left(1 - \frac{V_{GS}}{V_p}\right)$
(C) $I_{DSS} \left(\frac{\sqrt{V_{GS}}}{V_p}\right)$
(D) $I_{DSS}^2 \left(\frac{V_{GS}}{V_p}\right)$
18. Which has low power dissipation?
(A) NMOS
(B) PMOS
(C) BJT
(D) CMOS
19. Gallium arsenide is made up of:
(A) Single element
(B) Compound of two elements
(C) Compound of three elements
(D) Compound of four elements
20. P-well is created on _____.
(A) p substrate
(B) n substrate
(C) p & n substrate
(D) None of the mentioned

21. What are the types of MOSFET devices available?
- (A) P-type enhancement type MOSFET
 - (B) N-type enhancement type MOSFET
 - (C) Depletion type MOSFET
 - (D) All of the mentioned
22. NMOS is _____.
- (A) Donor doped
 - (B) Acceptor doped
 - (C) All of the mentioned
 - (D) None of the mentioned
23. The spacing of interconnect is scaled by:
- (A) α
 - (B) $1/\alpha$
 - (C) α^2
 - (D) $1/\alpha^2$
24. Concentration gradient refers to:
- (A) Change of concentration with respect to time
 - (B) Change of concentration with respect to space
 - (C) Change of concentration with respect to temperature
 - (D) None of the mentioned
25. When a junction transistor is operated under saturation conditions:
- (A) Both the CB and EB junction are forward biased
 - (B) The CB junction is forward biased but EB junction is reverse biased
 - (C) The CB junction is reverse biased but EB junction is forward biased
 - (D) None

26. A semiconductor has generally _____ valence electrons.
- (A) 2
 - (B) 3
 - (C) 4
 - (D) 6
27. What is the condition for saturation?
- (A) $V_{gs} = V_{ds}$
 - (B) $V_{ds} = V_{gs} - V_t$
 - (C) $V_{gs} = V_{ds} - V_t$
 - (D) $V_{ds} > V_{gs} - V_t$
28. A hole in a semiconductor is defined as_____.
- (A) A free electron
 - (B) The incomplete part of an electron pair bond
 - (C) A free proton
 - (D) None
29. Which method is most suitable for silicon crystal growth in silicon wafer preparation?
- (A) Float zone process
 - (B) Bridgeman-Stockbarger method
 - (C) Czochralski crystal growth process
 - (D) Laser heated pedestal growth
30. Which color is used for contact areas?
- (A) Red
 - (B) Brown
 - (C) Black
 - (D) Blue

31. To grow $1\mu\text{m}$ thick SiO_2 layer on the Si wafer which of the process is preferable?
- (A) Both dry and wet oxidation are equally preferable
 - (B) CVD
 - (C) Wet Oxidation
 - (D) Dry oxidation
32. In n channel MOSFET _____ is constant.
- (A) Channel length
 - (B) Channel width
 - (C) Channel depth
 - (D) Channel concentration
33. Electrical charge flows from _____.
- (A) Source to drain
 - (B) Drain to source
 - (C) Source to ground
 - (D) Source to gate
34. The leakage current across a pn junction is due to:
- (A) Minority carriers
 - (B) Majority carriers
 - (C) Junction capacitance
 - (D) None
35. Surface mobility depends on:
- (A) Channel length
 - (B) Effect gate Voltage
 - (C) Effect drain Voltage
 - (D) None

36. The _____ is used to reduce the resistivity of poly silicon.
- (A) Photo resist
 - (B) Etching
 - (C) Doping impurities
 - (D) None of the mentioned
37. The width of n-diffusion and p-diffusion layer should be?
- (A) 3λ
 - (B) 2λ
 - (C) λ
 - (D) 4λ
38. Design rules does not specify _____.
- (A) Linewidths
 - (B) Separations
 - (C) Extensions
 - (D) Colours
39. Which is the software used in VLSI?
- (A) Xilinx
 - (B) Cadence
 - (C) LOON
 - (D) All of the above
40. What is pinch off voltage?
- (A) A voltage at which the current gets pinched to zero
 - (B) Maximum voltage a FET can withstand
 - (C) Current amplification factor/voltage gain
 - (D) Minimum voltage required to turn on the FET

41. Inverters are essential for _____.
- (A) NAND gates
 - (B) NOR gates
 - (C) Sequential circuits
 - (D) All of the mentioned
42. Why MOSFET is preferred over BJT in IC components?
- (A) MOSFET has low packing density
 - (B) MOSFET has medium packing density
 - (C) MOSFET has high packing density
 - (D) MOSFET has no packing density
43. Which color is used for polysilicon?
- (A) Brown
 - (B) Red
 - (C) White
 - (D) Orange
44. _____ MOSFETs are always ON initially.
- (A) Enhancement
 - (B) Depletion
 - (C) Both (A) & (B)
 - (D) None of the above
45. Which is used as the dielectric layer in MOS Capacitor?
- (A) Silicon Nitride (Si_3N_4)
 - (B) Aluminium oxide (Al_2O_3)
 - (C) Tantalum oxide (Ta_2O_5)
 - (D) All of the mentioned

46. Oxidation in silicon can be occurred by raising _____.
(A) Pressure
(B) Humidity
(C) Temperature
(D) Volume
47. What is the second step in the IC fabrication?
(A) Doping
(B) Oxidation
(C) Metallization
(D) Orientation
48. Wafers properties depend upon the _____ of crystalline structures.
(A) Orientation
(B) Concentrations of impurity
(C) Presence of various impurities
(D) All the above
49. _____ is used in logic design of VLSI.
(A) LIFO
(B) FIFO
(C) FILO
(D) LILO
50. As die size shrinks, the complexity of making the photomasks _____.
(A) Increases
(B) Decreases
(C) Remains the same
(D) Cannot be determined

51. Inductor design in an IC:
- (A) Is possible with discrete components
 - (B) Is not possible
 - (C) Is possible
 - (D) None of the above
52. Etching is used for:
- (A) Protection
 - (B) Interconnection
 - (C) Selective removal of the unwanted surface
 - (D) None
53. Optical masking is used:
- (A) Etching
 - (B) Protection
 - (C) Pattern transfer
 - (D) Cleaning
54. Packaging is used for:
- (A) Protection
 - (B) Safety
 - (C) Both (A) & (B)
 - (D) None of the above
55. What is the crystal structure of silicon?
- (A) Face Centred Cubic
 - (B) Body Centred Cubic
 - (C) Diamond
 - (D) Hexagonal
56. Which color is used for n-diffusion in stick diagrams?
- (A) Red
 - (B) Blue
 - (C) Green
 - (D) Yellow

57. Metallization is used for:
- (A) Protection
 - (B) Interconnection
 - (C) Packaging
 - (D) None of the above
58. Find the application areas, where Schottky diode can be used?
- (A) Radio frequency
 - (B) Power rectifier
 - (C) Clamping diode
 - (D) All of the mentioned
59. The threshold voltage of an n-channel MOSFET can be increased by:
- (A) Reducing the channel dopant concentration.
 - (B) Reducing the channel length
 - (C) Reducing the gate oxide thickness.
 - (D) Increasing the channel dopant concentration.
60. An n-channel JEET has $I_{DSS} = 2 \text{ mA}$ and $V_p = -4 \text{ V}$. Its transconductance g_m (in milli mho) for an applied gate-to-source voltage V_{Gs} of -2 V is:
- (A) -8 V
 - (B) 0.5 V
 - (C) 0.75 V
 - (D) -2 V
61. Stick diagrams are those which convey layer information through?
- (A) Thickness
 - (B) Color
 - (C) Shapes
 - (D) Layers
62. FET has offset voltage of about:
- (A) Zero
 - (B) 0.2 V
 - (C) 0.5 V
 - (D) 1 V

63. The drain current in JFET is controlled by:
- (A) Channel resistance
 - (B) Voltage drop across channel
 - (C) Reverse-bias at the gate
 - (D) Depletion regions
64. n-channel FET's are superior to p-channel FET's because:
- (A) Mobility of electrons is smaller than that of holes
 - (B) They have high switching time
 - (C) Mobility of electrons is greater than that of holes
 - (D) They consume less power
65. The main factor, which differentiates a D-MOSFET from an E-MOSFET, in the absence of:
- (A) p-n Junction
 - (B) Channel
 - (C) Electrons
 - (D) Insulated gate
66. The threshold voltage of an n-channel enhancement mode MOSFET is 0.5 V. When the device is biased at a gate voltage of 3 V. Pinch-off would occur at a drain voltage of:
- (A) 2.5 V
 - (B) 0.5 V
 - (C) 3.0 V
 - (D) 3.5 V

67. Doping concentration of BJT is high in the:
- (A) Collector region
 - (B) Base region
 - (C) Emitter region
 - (D) None of the above
68. The LED is usually made of materials like:
- (A) GaAs
 - (B) Si
 - (C) GeAs
 - (D) None of the above
69. When a diode is forward-biased, the recombination of free electron and holes may produce:
- (A) Heat
 - (B) Light
 - (C) Radiation
 - (D) All of the above
70. For an enhancement-type MOSFET the output V-I characteristic of has:
- (A) Only a saturation region
 - (B) An ohmic region at low voltage value followed by a saturation region at higher voltages
 - (C) An ohmic region at large voltage values preceded by a saturation region lower voltage
 - (D) Only an ohmic region

71. What are the advantages of BiCMOS?
- (A) Higher gain
 - (B) High frequency characteristics
 - (C) Better noise characteristics
 - (D) All of the mentioned
72. The width of the depletion region is:
- (A) Independent of doping
 - (B) Inversely proportional to doping
 - (C) Directly proportional to doping
 - (D) One of the above
73. The probability that an electron in a metal occupies the Fermi-level, at any temperature ($>0\text{K}$) is:
- (A) 0
 - (B) 1
 - (C) 0.5
 - (D) None of the above
74. Inter-electrode capacitances in an FET are of the order of:
- (A) 1pF
 - (B) 100 pF
 - (C) 0.1 μF
 - (D) 1 μF
75. The pinch-off voltage of JFET is 5.0 volts. Its cut-off voltage is:
- (A) 2.5 V
 - (B) 5.0 V
 - (C) $(5.0)^{1/2}$ V
 - (D) $(5.0)^{3/2}$ V

76. The transistors used in BiCMOS are _____.
- (A) BJT
 - (B) MOSFET
 - (C) Both BJT and MOSFETs
 - (D) JFET
77. Doping means:
- (A) Addition of impurity material in semiconductor band structure
 - (B) Removing of impurity material in semiconductor band structure
 - (C) Cleaning the surface
 - (D) None of the above
78. Oxidation is used for:
- (A) Isolation
 - (B) Doping
 - (C) Interconnection
 - (D) None of the above
79. What is the advantage of using Ion implantation process?
- (A) Lateral spreading is more
 - (B) Performed at high temperature
 - (C) Beam current controlled from outside
 - (D) Performed at low temperature
80. Channel length modulation effect come after:
- (A) Pinch-off
 - (B) Saturation effect
 - (C) Drain source voltage
 - (D) None

81. Gallium is produced as a byproduct of:
- (A) Aluminium production process
 - (B) Sulphur production process
 - (C) Nitrogen production process
 - (D) Oxygen production process
82. CMOS inverter has _____ output impedance.
- (A) Low
 - (B) High
 - (C) Very high
 - (D) None of the mentioned
83. Switching speed of a MOS device depends on:
- (A) Gate voltage above a threshold
 - (B) Carrier mobility
 - (C) Length channel
 - (D) All of the mentioned
84. Transconductance gives the relationship between _____.
- (A) Input current and output voltage
 - (B) Output current and input voltage
 - (C) Input current and input voltage
 - (D) Output current and output voltage
85. Which component is not used as an impurity in diffusion process?
- (A) Phosphorous
 - (B) Boron chloride
 - (C) Phosphorous pentaoxide
 - (D) Boron oxide

86. Which of the following is added as an impurity to p-type material in diffusion process?
- (A) Phosphorous pentaoxide (P_2O_5)
 - (B) Phosphorous oxychloride ($POCl_3$)
 - (C) Boron oxide (B_2O_3)
 - (D) None of the mentioned
87. What is the advantage of using Surface Mount Technology (SMD)?
- (A) High speed
 - (B) Low power consumption
 - (C) Reduces heat dissipation in components
 - (D) Use leaded or leadless components
88. Which insulating layer used in fabrication of MOSFET?
- (A) Aluminium oxide
 - (B) Silicon Nitride
 - (C) Silicon dioxide
 - (D) None
89. If n-transistor conducts and has large voltage between source and drain, then it is said to be in _____ region.
- (A) Linear
 - (B) Saturation
 - (C) Cut-off
 - (D) High impedance
90. Which type of etching process is preferred to make the photoresist immune to etchants?
- (A) None of the mentioned
 - (B) Wet etching
 - (C) Plasma etching
 - (D) Chemical etching

91. The process involved in photolithography is:
- (A) Making of a photographic mask only
 - (B) Photo etching
 - (C) Both photo etching and making of photographic mask
 - (D) None of the mentioned
92. The advantage of Multi-emitter transistor is:
- (A) To reduce fabrication steps
 - (B) to save chip area
 - (C) To lower design consideration
 - (D) To provide linear output
93. How the aluminium film coating is carried out in metallization process?
- (A) Heating and pouring aluminium in required place.
 - (B) Aluminium is vacuum evaporated and then condensed
 - (C) Placing the aluminium in required place and then heating it using tungsten
 - (D) None of the mentioned
94. MOSFET is a _____ controlled device:
- (A) Current
 - (B) Voltage
 - (C) Resistance
 - (D) Impedance
95. After placing the mask over the photoresist the wafer is subjected to _____.
- (A) UV rays
 - (B) Visible light
 - (C) Infrared rays
 - (D) All of these.

96. _____ architecture is used to design VLSI.
- (A) System on a device
 - (B) Single open circuit
 - (C) System on a chip
 - (D) System on a circuit
97. The interconnections are made during _____.
- (A) Emitter diffusion process
 - (B) Photolithography process
 - (C) Epitaxial growth
 - (D) Metallization process
98. Which of the following components are not fabricated on IC?
- (A) Transistors
 - (B) Resistors
 - (C) Diodes
 - (D) Transformers
99. NMOS fabrication process is carried out in:
- (A) Thin wafer of a single crystal
 - (B) Thin wafer of multiple crystals
 - (C) Thick wafer of a single crystal
 - (D) Thick wafer of multiple crystals
100. Which of the following material is used to make IC?
- (A) Germanium
 - (B) Silicon
 - (C) Boron Nitride
 - (D) Copper

Rough Work / रफ कार्य

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